



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of: **Shigeo OHSAKA, et al.**

Group Art Unit: 2828

Serial No.: **09/456,531**

Examiner: **James A. Menefee**

Filed: **December 8, 1999**

P.T.O. Confirmation No.: **6582**

For: **ELECTRODE STRUCTURE, PROCESS FOR FABRICATING ELECTRODE
STRUCTURE AND SEMICONDUCTOR LIGHT-EMITTING DEVICE**

AMENDMENT UNDER 37 CFR §1.111

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

September 2, 2003

Sir:

In response to the Office Action dated **June 3, 2003**, please amend the above-identified
application as follows:

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TECHNOLOGY CENTER 2800